



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 30, 2026

IGI Report Number

LG821620766

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUSHION BRILLIANT

Measurements

11.81 X 7.50 X 4.43 MM

GRADING RESULTS

Carat Weight

3.22 CARATS

Color Grade

D

Clarity Grade

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG821620766

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS

Medium To Slightly Thick

17%

58%

38%

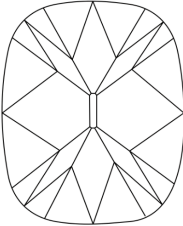
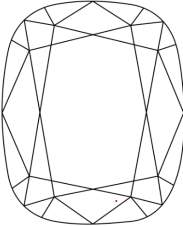
59.1%

Long Faceted

Sample Image Used



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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11.81 X 7.50 X 4.43 MM

Carat Weight

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Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

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